

Docket No.: 1268-093A



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Moshe FINAROV

U.S. Patent Application No. 09/626,793

Filed: July 26, 2000

: Confirmation No. 8657

: Group Art Unit: 2851

: Examiner: D. Esplin

For: APPARATUS FOR INTEGRATED MONITORING OF WAFERS AND FOR
PROCESS CONTROL IN THE SEMICONDUCTOR MANUFACTURING AND A
METHOD FOR USE THEREOF

PETITION FOR EXTENSION OF TIME

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Applicant hereby petitions the Commissioner of Patents and Trademarks to extend the time for response to the Official Action dated March 13, 2003 for *two* months from *June 13, 2003* to *August 13, 2003*.

A credit card authorization form to cover the Petition Fee. Any deficiency or overpayment should be charged or credited to Deposit Account No.: 07-1337.

Respectfully submitted,

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